

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/641,143	PARK ET AL.	
Examiner		Art Unit		Page 1 of 1
Chen-Wen Jiang		3744		

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0035133 A1	02-2004	Park et al.	62/324.1
*	B	US-2004/0035135 A1	02-2004	Park et al.	62/324.6
	C	US-			
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	E	US-			
	F	US-			
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	I	US-			
	J	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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